

RRAM – The Next “Flash”

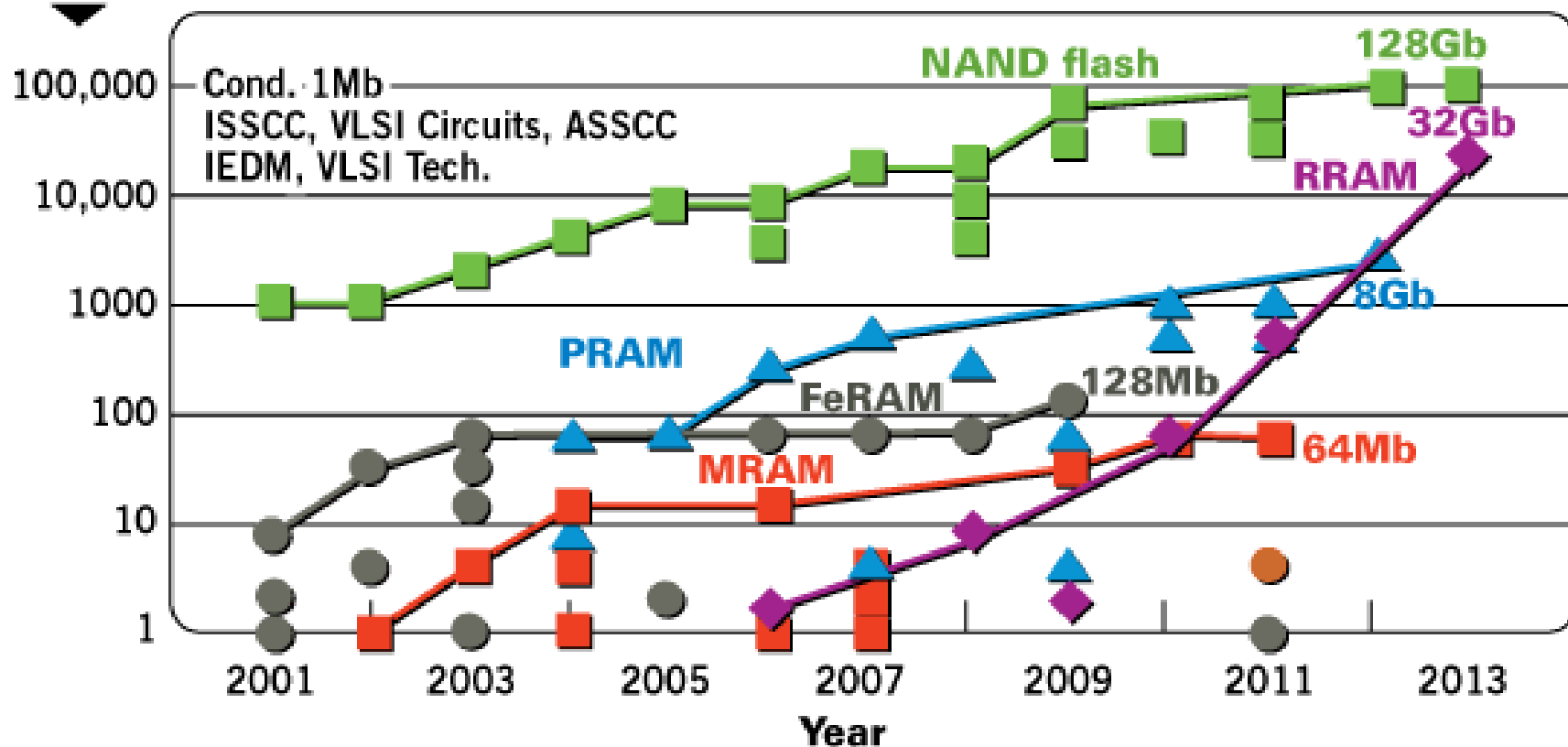


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Non-Volatile Memory Trends

Storage capacity (Mb)

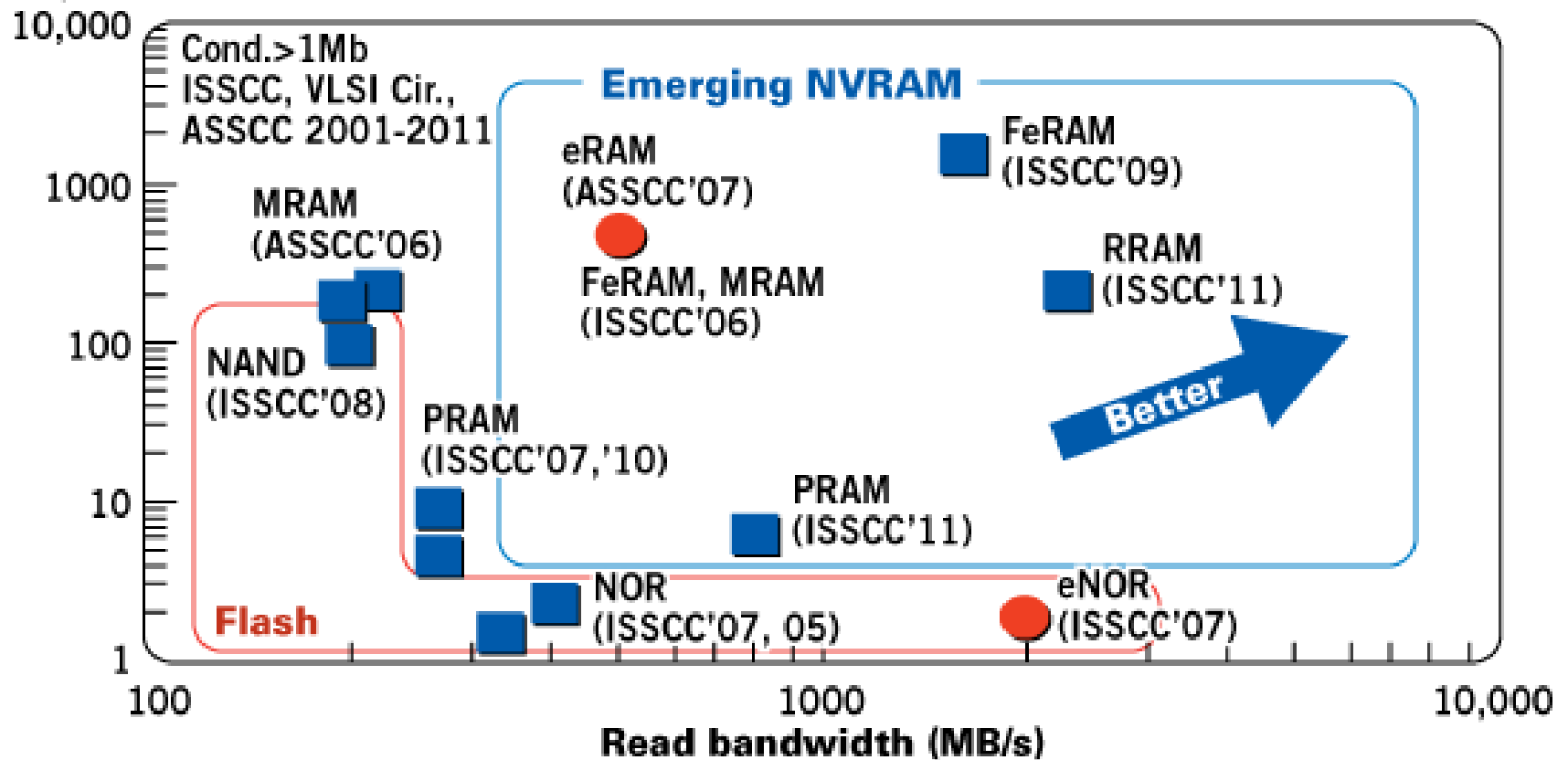


K. Zhang, Intel, ISSCC 2013



Non-Volatile Memory Trends

Write bandwidth (MB/s)



K. Zhang, Intel, ISSCC 2013

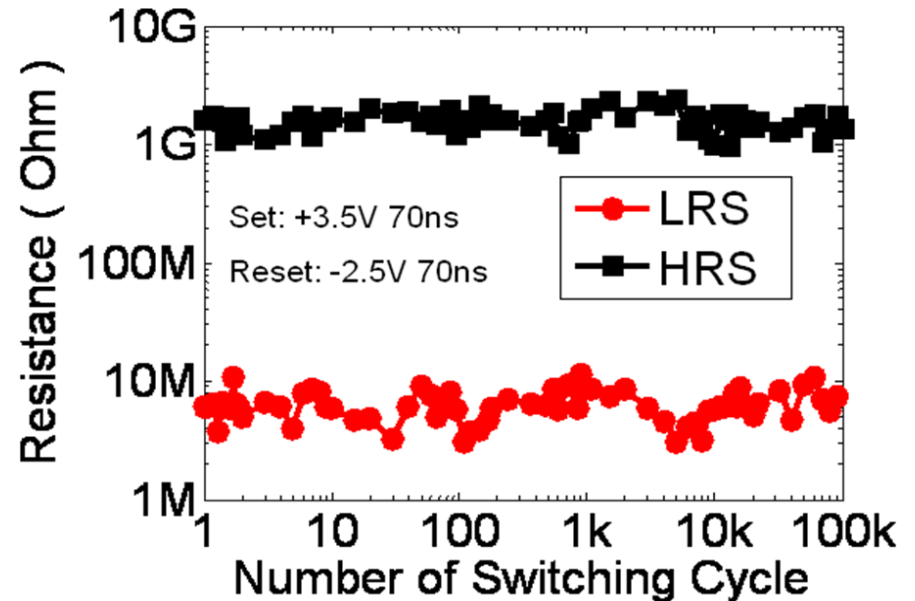
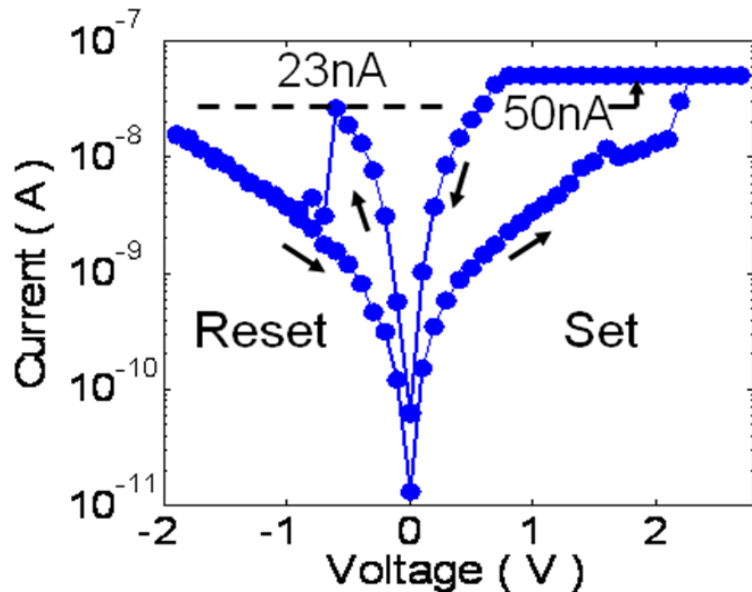


RRAM Benchmarks

	TaO _x IEDM 2008	HfO _x IEDM 2008	HfO _x IEDM 2009 &2010	N:AlO _x VLSI 2011	TaO _x / Ta ₂ O ₅ VLSI 2011	Hf/HfO _x IEDM 2011	Hf/HfO _x IEDM 2012	Ni/HfO _x IEDM 2012	TaO ₂ O _{5-δ} /TaO _x VLSI 2012	Al ₂ O ₃ /H fO ₂ /Hf VLSI 2012	Nb ₂ O ₅ /NbO ₂ VLSI 2012
Switching type	bipolar	bipolar	Bipolar	bipolar	bipolar	bipolar	bipolar	bipolar	bipolar	bipolar	bipolar
Structure	1T-1R	1T-1R	1T-1R	1T-1R	1R	1T-1R	1T-1R	1T-1R	1T-1R	1T-1R	1S-1R
Cell Area (μm ²)	~0.25	~0.1	0.0009 (30nm)	1	~9000	0.0001 (10nm)	0.0016(40nm)	0.0014	0.0324	0.0035	0.0225
Speed	~10ns	~5ns	~300ps	N/A	~10ns	~10ns	~10ns	~50ns	N/A	~10ns	~10us
DC Peak Voltage	<2V	<1.5V	<2.5V	<2V	<2.5V	<1.5V	<1.5V	<4.5V	<3V	<2V	<2V
DC Peak Current	~17μA	~25μA	~200 μA	~50nA	~30μA	~50 μA	~25μA	~200pA	~80μA	~500nA	~800μA
HRS/LRS Ratio	>10	>1,000	>1000	>100	>100	>10	>10	>10	>1000	>10	>10
Endurance	10 ⁹	10 ⁶	10 ¹⁰	10 ⁵	10 ¹²	5x10 ⁷	10 ⁷	10 ⁵	N/A	10 ⁷	10 ⁶
Retention	3000h @ 150°C	10h@ 200°C	28h@ 150°C	28h@ 125°C	3h@ 200°C	30h@ 250°C	3h@ 200°C	10yr@8 5°C	100h@ 150°C	3h@25 0°C	N/A

Low Programming Energy, High Endurance Cycles

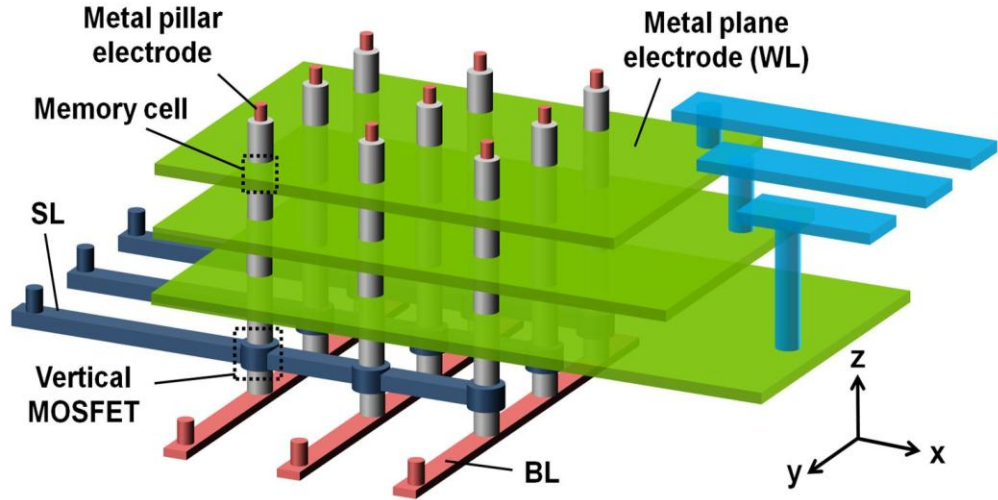
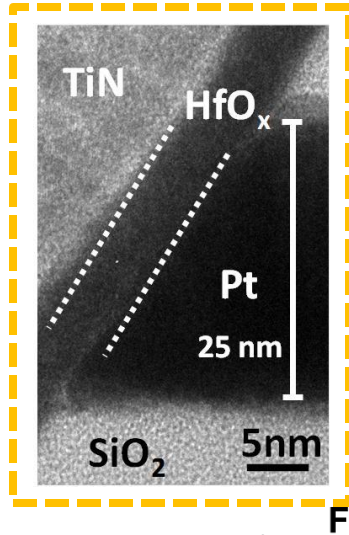
Nitrogen doped AlOx



W. Kim...S.S. Wong, *Symp. VLSI Technology*, June 2011



3D RRAM



H.-Y. Chen ... H.-S. P. Wong, IEDM 2012
 S. Yu ... H.-S. P. Wong, Symp. VLSI Tech. 2013

